

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant : Uzoh et al.  
Appl. No. : 10/698,878  
Filed : October 31, 2003  
For : METHODS AND DEPOSITING  
HIGH YIELD AND LOW  
DEFECT DENSITY  
CONDUCTIVE FILMS IN  
DAMASCENE STRUCTURES  
Examiner : Luan V. Van  
Group Art Unit : 1753  
Confirmation No. : 1999

**RESPONSE TO OFFICE ACTION**

**Mail Stop Amendment**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed on August 2, 2006, please amend the above-captioned application as set forth herein. A one-month extension of time is hereby requested.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 5 of this paper.